



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Wallace T.Y. Tang  
Serial No. : 09/134,147  
Filed : August 14, 1998  
Title : IN-SITU REAL-TIME MONITORING TECHNIQUE AND APPARATUS FOR  
DETECTION OF THIN FILMS DURING CHEMICAL/MECHANICAL  
POLISHING PLANARIZATION

Commissioner for Patents  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Applicant submits copies of the references listed on the attached form PTO-1449.

This filing is being made with the filing of a Request for Continued Examination. No fee  
is required.

Respectfully submitted,

Date: 12/3/02

David J. Goren  
David J. Goren  
Reg. No. 34,609

Telephone: (650) 839-5070  
Facsimile: (650) 839-5071

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

Date of Deposit December 3, 2002  
[Signature]  
Signature

Nikia M. Mc Nillion  
Typed or Printed Name of Person Signing Certificate

RECEIVED  
DEC 09 2002  
TC 1700  
#11  
1/28/03  
mw